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SCULLY, SCOTT, MURPHY
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Fax

To:	Examiner: Douglas W. Owens Art Unit: 2811	From:	Leslie S. Szivos
Fax:	571-273-8300	Pages:	6 pages including fax cover sheet
Phone:		Date:	7/7/2006
Re:	U.S. Patent Appn. No. 10/710,821 Filed: August 5, 2004 Docket BUR920040015US1 (17427) Confirmation No. 6753	CC:	

RESPONSE TO OFFICE ACTION

Please see the following documents:

1. General Transmittal (in duplicate)
2. Authorization to charge IBM deposit account
3. Response under 37 C.F.R. §§ 1.111 and 1.143 (2 pages)
4. Certificate of transmission by facsimile dated July 7, 2006

If you have any questions concerning this facsimile please contact Vivian Henriquez at 516-742-4343.
Thank you.

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)

Applicant(s): Matthew J. Breitwisch, et al.

JUL 07 2006

Docket No.

BUR920040015US1 (17427)

Application No.
10/710,821Filing Date
August 5, 2004Examiner
Douglas W. OwensGroup Art Unit
2811Invention: **ISOLATED FULLY DEPLETED SILICON-ON-INSULATOR REGIONS BY SELECTIVE ETCH**

I hereby certify that this

RESPONSE UNDER 37 C.F.R. §§1.111 AND 1.143*(Identify type of correspondence)*is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. **571-273-8300**)on **July 7, 2006***(Date)***Leslie S. Szivos, Ph.D.***(Typed or Printed Name of Person Signing Certificate)**(Signature)***Note: Each paper must have its own certificate of mailing.**

JUL 07 2006

Docket No.

BUR920040015US1 (17427)

**TRANSMITTAL LETTER
(General - Patent Pending)**

In Re Application Of: Matthew J. Breitwisch, et al.

Application No. 10/710,821	Filing Date August 5, 2004	Examiner Douglas W. Owens	Customer No. 23389	Group Art Unit 2811	Confirmation No. 6753
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Title: ISOLATED FULLY DEPLETED SILICON-ON-INSULATOR REGIONS BY SELECTIVE ETCH

COMMISSIONER FOR PATENTS:

Transmitted herewith is:

RESPONSE UNDER 37 C.F.R. §§1.111 AND 1.143

in the above identified application.

- No additional fee is required.
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Signature

Dated: July 7, 2006

Leslie S. Szivos, Ph.D.
Registration No. 39,394
SCULLY, SCOTT, MURPHY & PRESSER, P.C.
400 Garden City Plaza - Suite 300
Garden City, New York 11530

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on _____.

(Date)

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P16A/REV03

JUL 07 2006

Docket No.

BUR920040015US1 (17427)

TRANSMITTAL LETTER
(General - Patent Pending)

In Re Application Of: Matthew J. Breitwisch, et al.

Application No. 10/710,821	Filing Date August 5, 2004	Examiner Douglas W. Owens	Customer No. 23389	Group Art Unit 2811	Confirmation No. 6753
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Title: ISOLATED FULLY DEPLETED SILICON-ON-INSULATOR REGIONS BY SELECTIVE ETCH

COMMISSIONER FOR PATENTS:

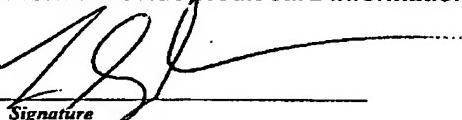
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE JUL 07 2006

Applicants: Matthew J. Breitwisch, et al. **Examiner:** Douglas W. Owens

Serial No.: 10/710,821 **Art Unit:** 2811

Filed: August 5, 2004 **Docket:** BUR920040015US1 (17427)

For: ISOLATED FULLY DEPLETED SILICON-ON-INSULATOR REGIONS BY
SELECTIVE ETCH

Confirmation No. 6753 **Dated:** July 7, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. §§1.111 AND 1.143

Sir:

In response to the Office Action dated June 8, 2006, applicants provisionally elect, without traverse, the subject matter of Group II, i.e., Claims 1-17 for continued prosecution in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: July 7, 2006



Leslie S. Szivos